210313US2 SRD



IN RE APPLICATION OF

Akira NISHIYAMA, et al

: EXAMINER: MAI, A.D.

SERIAL NO: 09/891,129

FILED: June 26, 2001

: GROUP ART UNIT: 2814

FOR: SEMICONDUCTOR DEVICE AND METHOD...

LETTER REQUESTING APPROVAL OF DRAWING CHANGES

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

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Please review for approval the proposed changes to Figures 1, 2A, 2B as

nown in red on the attached photocopies of the Figures.

Respectfully submitted,

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